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## \*BIBDATASHEET\*

CONFIRMATION NO. 4337

Bib Data Sheet

<b>SERIAL NUMBER</b> 10/603,924	<b>FILING OR 371(c) DATE</b> 06/24/2003 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2813	<b>ATTORNEY DOCKET NO.</b> JC-7109-CIP
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## APPLICANTS

Shao-Chung Hu, Taipei, TAIWAN;  
 Teng-Chun Tsai, Hsinchu, TAIWAN;  
 Chia-Lin Hsu, Taipei, TAIWAN;  
 Yung-Tsung Wei, Tainan Hsien, TAIWAN;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CON of 09/854,006 05/10/2001 PAT 6,696,361

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

TAIWAN 90109738 04/24/2001

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 11/11/2003

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	<b>STATE OR COUNTRY</b> TAIWAN	<b>SHEETS DRAWING</b> 4	<b>TOTAL CLAIMS</b> 12	<b>INDEPENDENT CLAIMS</b> 2
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

## ADDRESS

23900

## TITLE

METHOD OF REMOVING CONTAMINANTS FROM A SILICON WAFER AFTER CHEMICAL-MECHANICAL  
 POLISHING OPERATION

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